

Notice of References Cited	Application/Control No. 10/814,799	Applicant(s)/Patent Under Reexamination BAE ET AL.	
	Examiner Chen-Wen Jiang	Art Unit 3744	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0043073 A1	04-2002	Park et al.	62/231
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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